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)! 	N 0 8 2004 5	· · ·	IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
THE .	In re pai	∷ tent application	of
<i>y</i> ,	In re date Applicant Serial N Filed: For: Art Unit: Examine	Octobe PHASI FABRI 1756	taine, et al. 5,923 er 1, 2003 E-SHIFT REFLECTIVE MASK FOR LITHOGRAPHY, AND METHOD OF USING AND ICATING t assigned
			INFORMATION DISCLOSURE STATEMENT
*	P.O. Box	ssioner for Pate x 1450 ria, VA 22313-	
	Sir:		
	copy of e following U.S. pat	to the patents, each listed doc g application(s) ent or U.S. pat	37 C.F.R. 1.97 and 1.98, and in compliance with 37 C.F.R. 1.56, the Office's attention is pending applications, publications and other information listed on the attached PŢO-1449. A ument is enclosed, except for (a) those previously cited or submitted to the Office in the upon which this application relies for an earlier filing date under 35 U.S.C. 120, and (b) any tent application publication if the present application was filed after June 30, 2003 or entered or 35 USC § 371 after June 30, 2003:
<u>:</u>		Serial No.: Filing Date:	
	Applicar although	nt(s) believe(s)	the same may qualify as "prior" art to this application and should be treated accordingly, eserve(s) the right to contest the prior art status of any document, publication or information,
		anies this State	ach listed document that is not in the English language, an English-language translation ement as indicated on the attached PTO-1449 or a concise explanation of the relevance of the in the following document(s):
		(a)	A copy of each English language version of a search report (or EPO Search Report) indicating the degree of relevance found by the foreign office of each document being submitted from the search report, is being submitted herewith or has previously been submitted.
		(b)	Attached is a "Concise Explanation of Relevance of Non-English Language Documents".
	3.	Pursuant to 3	7 C.F.R. 1.97(b) this Statement is being filed (one must be checked):

Within 3 months of the filing date or date of entry into the National Stage.

submission after final rejection under 37 C.F.R. 1.129(a).

Before the mailing date of a first Office Action on the merits. If this Statement is not filed before the mailing date of a first Office Action on the merits, the required certification is given below or, in the absence thereof, the Office is authorized to charge the required fee set forth in 37 C.F.R. 1.17(p) to Deposit Account No. 18-0988 for consideration of this

Before the mailing date of a first Office Action on the merits after a first or second

(a) ___

(b)<u>X</u>

(c) ____

Statement.

	(d)		After the period set forth in 37 C.F.R. 1.97(b) but before the mailing date of either a final action or a notice of allowance.
	(1)	The required certification is given below, or
	(2	2)	Enclosed is a check covering the fee set forth in 37 C.F.R. 1.17(p) for consideration of this Statement, or
	(3	3)	Charge the fee set forth in 37 C.F.R. 1.17(p) to Deposit Account No. 18-0988
	(e)		After the mailing date of either a final action or a notice of allowance, but before payment of the issue fee. Petition hereby is made for consideration of this Statement and the required certification is indicated below.
	('	1)	Enclosed is a check covering the fee set forth in 37 C.F.R. 1.17(p), or
	(2	2)	Charge the fee set forth in 37 C.F.R. 1.17(p) to Deposit Account No. 18-0988.
4.	Certifica	ation (if	f applicable)
	(a)		The undersigned hereby certifies that each item of information contained in this Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than 3 months prior to the filing of this Statement.
	(b)		The undersigned hereby certifies that no item of information contained in this Statement was cited in a communication from a foreign patent office in a counterpart foreign application, and, to the undersigned's knowledge after making reasonable inquiry, no item of information contained in this statement was known to any individual designated in 37 C.F.R. 1.56(c) more than 3 months prior to the filing of this Statement.
5. Deposit A			ioner is hereby authorized to charge any additional fees or credit any overpayment to 0988.
			Respectfully submitted,
			RENNER, OTTO, BOISSELLE & SKLAR, LLP
			Jønathan A. Platt, Reg. No. 41,255
1621 Euc Cleveland (216) 621	d, Ohio		th Floor
			CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8
deposited	d on the b	below o	correspondence (along with any paper referenced as being attached or enclosed) is being date with the United States Postal Service with sufficient postage as first class mail in an Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450
Date:J	January 6	<u>6, 2004</u>	Jøbethan A. Platt
\robs-2k\secret	tary\SEC109\F	Platt-ja\AM[DS\H series\H1567us\amdsph1567us.ids-1449.wpd)

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Forr	भू PTO-1449 (Modified)	
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LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S FORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

Atty Docket No.	Serial No.
H1567	10/676,923
Applicant:	
LaFontaine, et al.	
Filing Date	Group
10/1/03	1756

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date (MM/YYYY)	Name	Class	Sub- class	Filing Date if Appropriate
	6,356,340	3/2002	Spence			
	6,535,280	3/2003	LaFontaine, et al.			
	6,555,274	4/2003	Kye, et al.			
	6,556,286	4/2003	LaFontaine, et al.			

FOREIGN PATENT DOCUMENTS

Examiner Initial	Document Number	Date (MM/YYYY)	Country	Class	Sub- class	Translation	
Illitial		(INIAN LL LL)			Class	Yes	No
		7				1	17.7

OTHER ART

Examiner Initial	Author, Title, Date, Pertinent Pages, etc.
	Deng, et al. Rigorous EM Simulation of the Influence of the Structure of Mask Patterns on EUVL Imaging, Electronics Research Laboratory and Department of Electrical Engineering and Computer Sciences, University of California at Berkeley, Berkeley, California. Proceedings of the SPIE, Volume 5037, pp. 302-313 (6/2003).

EXAMINER	DATE CONSIDERED			

EXAMINER:

Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Information Disclosure Statement PTO-1449 (Modified)

The identification of any reference is not intended to be, and should not be understood as being, an admission that such publication, in fact, constitutes "prior art" within the meaning of applicable law since, for example, a given reference may have a later effective date than first seems apparent or the reference may have an effective date which can be antedated. The "prior art" status of any reference is a matter to be resolved during prosecution. \\robs-2k\secretary\SEC109\Platt-ja\AMDS\H series\H1567us\amdsph1567us.ids-1449.wpd (IDS1449.FRM) (2/97)